Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L6	3	"2001228616"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 16:04
S5	502892	mask	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:36
S7	94917	(T-shap\$2) or (t adj shap\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:00
S8	2961026	top	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:37
S9	2559734	bottom	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:38
S10	67	polymethylglutarimide	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:38
S11	70	polymethylglutarimide or PMGM	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:38
S12	56	(phenol adj hydroxide) or (phenol-based adj hydroxide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:39
S13	8478	water-soluble adj resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:39
S14	491	"no" adj crosslinking adj agent	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:41

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S15	. 1	S13 near S14	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:40
S16	73488	crosslinking adj agent	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:41
S18	101	S13 near S16	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:42
S19	43651	RIE or (reactive adj ion adj etch)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 09:42
S21	520406	resist or photoresist	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 10:59
S22	. 1637560 <sub>.</sub>	pattern	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 10:59
S23	94917	(T-shap\$2) or (t adj shap\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:04
S26	112581	(T or cross) adj shap\$2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:05
S27	10265	S26 and S21	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:06
S28	8478	water-soluble adj resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:06

C20		C27 and C20	110 000:15	00	ON	2005/10/10 11 65
S29	5	S27 and S28	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:06
S30	70	polymethylglutarimide or PMGM	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:20
S31	13	S27 and S30	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	O <sub>.</sub> N	2005/10/19 11:06
S32	56	(phenol adj hydroxide) or (phenol-based adj hydroxide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 11:06
S35	1	10/731088	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:15
S36	17253	thin adj film adj magnetic adj head	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:15
S37	5616	S36 and S21	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:16
S38	178	S37 and S23	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:16
S39	77962	melamine	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ÓΝ	2005/10/19 12:16
S40	1	S38 and S39	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:17

S41	301906	sulfone or alkin or urea or melamine	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:18
S42	1	S38 and S41	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:18
S43	98	S36 and S41	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:25
S44	26	S43 and (NQD or novolak)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 12:26
S46	2	S44 and (PMGI or polymethyglutarimide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 13:08
S47	13	increase near surface near area near (photo or photoresist or resist)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 14:16
548	301906	sulfone or alkin or urea or melamine	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 14:17
S50	2640	S48 and (increase adj surface)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 14:17
S51	430	S50 and resist	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 14:18
S52	14	S50 and (resist near surface)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/19 14:22